



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

July 11, 2026

IGI Report Number

LG812608592

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

HEXAGONAL MODIFIED
BRILLIANT

Measurements

9.63 X 5.08 X 3.32 MM

GRADING RESULTS

Carat Weight

1.10 CARAT

Color Grade

D

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

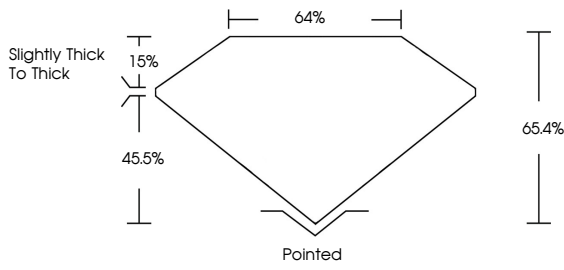
Inscription(s)

 LG812608592

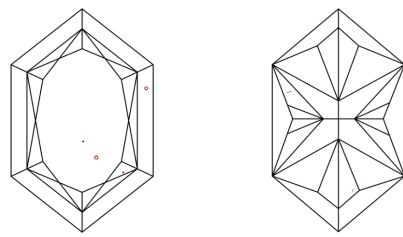
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

LABORATORY GROWN DIAMOND REPORT

July 11, 2026

IGI Report Number

LG812608592

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

HEXAGONAL MODIFIED
BRILLIANT

Measurements

9.63 X 5.08 X 3.32 MM

GRADING RESULTS

Carat Weight

1.10 CARAT

Color Grade

D

Clarity Grade

VS 2

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

Inscription(s)

 LG812608592

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

IGI



© IGI 2020, International Gemological Institute

FD - 10 20

July 11, 2026

IGI Report No LG812608592

HEXAGONAL MODIFIED BRILLIANT

9.63 X 5.08 X 3.32 MM

Carat Weight

1.10 CARAT

D

Color Grade

D

VS 2

Clarity Grade

VS 2

65.4%

Table

64%

Slightly Thick To Thick

Grade

Slightly Thick To Thick

Pointed

Culet

EXCELLENT

EXCELLENT

Polish

EXCELLENT

NONE

Symmetry

EXCELLENT

NONE

Fluorescence

NONE

 LG812608592

Inscription(s)

 LG812608592

Comments: The Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa